Method for fastening chips with a contact element onto a substrate provided with a functional layer having openings for the chip contact elements

This invention relates to a method for tacking of chips onto a substrate at chip positions which are distributed on a surface of the substrate ~~as claimed in Claim 1~~.

Chips are often joined via bumps to bond pads embedded in a substrate, therefore electrically conductive contacts. To bridge the distance between the chips and the substrate and to produce a mechanical connection between the chip and the substrate, underfill materials are used which are also employed for mechanical relief of the bumps from the chip or substrate. The underfill material increases the service life of the chips several-fold. Mainly the fatigue strength of the bond connection at complete stress reversal with respect to temperature changes and/or mechanical loads is increased.

In practice an underfill material with low viscosity is placed between the chips and the substrate by capillary action after the underfill material has been applied for example by inkjet methods or centrifugal acceleration methods. The aforementioned methods limit the choice of materials, and at short distances between the chips and the substrate surface, for example less than 50 μm, the aforementioned sequence is very time-consuming or can no longer be implemented.

One alternative method therefore consists in applying the underfill material before applying the chips to the substrate, especially at very small distances between the chips and the substrate surface. The underfill material is laminated for example as a film onto the substrate, applied by spin coating or spray coating or is distributed on the substrate by application of pasty material.

So that the chips which have been seated on the underfill material do not slip on the substrate up to the bonding which is generally carried out in a separate chamber, the chips are fixed

beforehand in their respective chip position which is aligned with the substrate, especially by "tacking". This has the advantage that the entire substrate can be provided with chips and only then can the bonding process be carried out for all chips.

In this procedure however the electrically conductive connection between the chips and the substrate poses technical problems; this connection takes place recognizably by bumps or pins which extend from the chips to corresponding contacts in the substrate. Another technical problem is the choice of material properties of the underfill material since on the one hand it is intended to have an adhesive action (for tacking) and on the other hand a support function. Moreover the underfill material should have as little effect on the alignment accuracy as possible. At the same time the processing of the underfill material, especially during tacking and/or bonding, will take place as promptly as possible.

Embodiments~~The object~~ of this invention disclose~~is therefore to devise~~ a method for tacking of chips onto a substrate with high throughput and high alignment accuracy as well as improved electrical contact-making of the chips.

~~This object is achieved with the features of Claim 1. Advantageous developments of the invention are given in the dependent claims.~~According to a first aspect, there is provided a method for tacking of chips onto a substrate at chip positions which are distributed on a surface of the substrate, said method comprising: forming or applying a function layer onto the surface of the substrate, after forming or applying the function layer onto the surface of the substrate, removing

the function layer from the surface of the substrate at the chip positions at least in the region of contacts to uncover the contacts, tacking chips onto a chip contact side of the function layer at the chip positions and contacting the chips with the contacts via contact elements.

According to a second aspect, there is provided a method for tacking of chips onto a substrate at chip positions which are distributed on a surface of the substrate, said method comprising: forming or applying a function layer onto the surface of the substrate; after forming or applying the function layer onto the surface of the substrate, removing the function layer from the surface of the substrate at the chip positions at least in the region of contacts to uncover the contacts; and tacking chips onto a chip contact side of the function layer at the chip positions and contacting the chips with the contacts via contact elements, wherein the ratio of (i) a distance between contact elements to (ii) a height difference between a lower surface of each chip and the surface of the substrate, is between 3:1 and 1:2.

All combinations of at least two of the features given in the specification, the claims and/or the figures also fall within the scope of the invention. At the given value ranges, values within the indicated limits will also be considered to be disclosed as boundary values and will be claimed in any combination.

The basic idea of embodiments of this invention is to make the function layer as per embodiments of~~claimed in~~ the invention at the chip positions at least in the region of the contacts such that there is a free space for contact elements for making electrical contact of the chips with the contacts of the substrate. This leads as

~~claimed in~~per embodiments of the invention to a higher throughput and thus to an economical and/or technical advantage.

Chip positions are the areas on the surface of the substrate on which the chips are positioned with a distance parallel to the substrate surface. The electrical contact-making takes place via contact elements, especially bumps or pins. The contacts can have a structure which can equalize tolerances with respect to the distance between the chip and wafer. For example let a contact be mentioned which consists of a serial sequence of a metal and an alloy, the alloy having a lower melting point. Upon contact of the chip with the wafer via the contacts, at an operating temperature which is above the melting point of the alloy, the latter melts on so that better parallelism between chip and wafer can be produced. The just mentioned serial version of a contact can be located not only on the bottom of a chip, but also on the top of the corresponding wafer. The serial version is also conceivable on chip and wafer.

The aforementioned measures as per embodiments of~~claimed in~~ the invention in concert or individually improve the electrical contact-making of the chips and increase the alignment accuracy at the same time since the function layer need not be penetrated by the contact elements. Moreover the choice of available materials for the function layer is expanded since neither is a capillary action necessary to deliver the function layer between the chips and the substrate surface, nor is penetration of the function layer with the contact elements with the expenditure of a displacement force necessary. This is especially advantageous for applications which require a very short distance between the chips and the substrate surface, since for distances of < 50 μm, especially < 30 μm, for simultaneously large-area chips conventional methods based on capillary action no longer work. Generally an increase of the contact density of the pins or bumps is accompanied by a reduction of

the distance between the chips and the substrate surface. The ratio of the distance between the bumps, the so-called contact pitch, to the height difference between the chip and substrate surface is between 3:1 and 1:2 as per embodiments of~~claimed in~~ the invention.

According to one advantageous embodiment of the invention it is provided that the function layer is treated with a solvent on the chip contact side, especially immediately before tacking, in order to induce an adhesion property which is necessary for tacking. In this measure as per embodiments of~~claimed in~~ the invention the use of an adhesive material for the function layer can be omitted. The tacking takes place especially via a solvent which is applied to one contact side of the chips and/or to the function layer. In particular a very small amount of solvent is applied, preferably less than 1 ml per mm^2, more preferably less than 0.1 ml per mm^2, still more preferably less than 0.01 ml per mm^2, most preferably less than 0.001 ml per mm^2. Thus the solvent as per embodiments of~~claimed in~~ the invention can be applied either in a blanket manner to the function layer and/or to the contact side of each chip. Upon contact of the chip with the function layer, a tacking layer of the function layer on the chip contact side liquefies and the chips are tacked onto the function layer by at least partial evaporation of the solvent. The tacking layer is more or less converted back into the function layer.

Alternatively, according to one advantageous embodiment of the invention it is provided that the function layer on the chip contact side be provided with an adhesion layer, especially with a temporary adhesive. This version has the advantage that for the function layer exactly the desired physical and/or chemical properties can be chosen by material selection, while an adhesion layer is responsible solely for the tacking and accordingly can be optimally selected.

In a further alternative the adhesion layer can be applied to the chips, preferably only immediately before placement of the chips.

In another embodiment it is possible for the function layer to have a so-called B-stage property. Materials with B-stage properties can change from one state into another by temperature and/or UV light and/or other known chemical and/or physical processes. In this case, thus in particular a crosslinking of the polymer material of the function layer which is to take place only after placement would be intended. These B-stage properties are known to one skilled in that art mainly, but not solely, from the IC packaging domain.

It is conceivable for the thickness of the function layer prior to the bond process of the chip onto the wafer to be greater than the distance between the bottom of the chip and the top of the chip. This layer is then compressed and/or displaced accordingly by a compressive force. In this way it is preferably guaranteed that the volume between the chip and substrate is completely filled.

In the two aforementioned alternative embodiments it is provided ~~as claimed in the invention~~ that the solvent or the adhesion layer be completely evaporated, especially without residue, in the subsequent bonding process.

To the extent uncovering additionally comprises uncovering of the exposed area of the surface located outside the chip positions, influencing the alignment results by thermal expansion of the function layer is minimized. In particular, the exposed areas are made such that parts of the final packaging there, especially consisting of a molding compound, can adhere to the latter.

In an embodiment~~a development~~ of the invention it is provided that the uncovering additionally encompasses a formation of channels in the function layer. This on the one hand further minimizes influence by thermal expansion of the function layer and on the other hand any pressure fluctuations in the cavities of the function layer are equalized by the channels, especially when they run to the contacts or free space which has been produced by the uncovering as far as the exposed area or the

vicinity.

The function layer consists of material which has a low elasticity, especially a modulus of elasticity greater than 10 kN per mm^2, preferably greater than 20 kN per mm^2. In this way alignment errors by movements of the function layer are largely avoided.

According to another advantageous embodiment, the uncovering of the contacts and/or the uncovering of the exposed area and/or of the channels takes place by photostructuring, especially the steps being the following, preferably the sequence being the following:

- exposure of the function layer with a corresponding mask,

- stripping (removal) of the areas to be uncovered.

According to another embodiment of the invention, it is advantageously provided that when the contacts are uncovered, through openings are formed in the function layer, which openings extend as far as the contacts and are arranged especially concentrically to the contacts, especially with a diameter D_1 greater than a diameter D_2 of the contact elements. This configuration largely minimizes stress on the edges of the through openings. This approach applies analogously to square or rectangular contacts.

A substrate with a function layer which has been applied to the surface of the substrate and which is uncovered at chip positions in the region of the substrate contacts, is disclosed as another embodiment~~an independent~~ invention, especially produced by a method which was described above.

In a development of the substrate, it is advantageously provided as per embodiments of~~claimed in~~ the invention for the substrate to have chips which are tacked onto one chip contact side of the function layer at the chip positions and which are electrically connected via contact elements to the contacts of the substrate.

Claims

1. A method for tacking of chips (4) onto a substrate (1) at chip positions (1c) which are distributed on a surface (1o) of the substrate (1) with the following steps, especially the following sequence:

- formation or application of a function layer (7) onto the substrate (1)

  a) which layer has been uncovered at the chip positions (1c) at least in the region of contacts (2) by structuring or

  b) by uncovering of a function layer (7) which has been uncovered on the surface (1o) at the chip positions (1c) at least in the region of the contacts (2) after formation or application of the function layer (7),

- tacking of chips (4) onto one chip contact side (7o) of the function layer (7) at the chip positions (1c) and contact-making of the contacts (2) via contact elements (3), wherein the ratio of (i) a distance between the contact elements (3) to (ii) a height difference between a lower surface of each chip (4) and the surface (1o) of the substrate (1) is between 3:1 and 1:2.

2. The method as claimed in Claim 1, wherein the function layer (7) is treated with a solvent on the chip contact side (7o), especially immediately before tacking, in order to induce an adhesion property which is necessary for tacking.

3. The method as claimed in one of the preceding claims, wherein the function layer (7) is provided with an adhesion layer on the chip contact side (7o).

4. The method as claimed in one of the preceding claims, wherein the uncovering comprises in addition an uncovering of an exposed area (1f) of the surface (1o) located outside the chip positions (1c).

5. The method as claimed in one of the preceding claims, wherein the uncovering additionally comprises a formation of channels (8) in the function layer (7), especially beginning from the

contacts (2), preferably ending on the exposed area (1f).

6. The method as claimed in one of the preceding claims, wherein the function layer (7) consists of a material which has low elasticity.

7. The method as claimed in one of the preceding claims, wherein the uncovering of the contacts (2) and/or the uncovering of the exposed area (1f) and/or the formation of the channels (8) takes place by photostructuring, especially with the following steps:

- exposure of the function layer (7) on the areas which are to be uncovered,
- lithography of the areas which are to be uncovered and
- stripping of the areas which are to be uncovered.

8. The method as claimed in one of the preceding claims, wherein when the contacts (2) are uncovered, through openings (9) are formed in the function layer (7), which openings extend as far as the contacts (2) and are arranged especially concentrically to the contacts (2), especially with a diameter D_1 greater than a diameter D_2 of the contact elements (3).

9. The method as claimed in one of the preceding claims, wherein the chips (4) are aligned with the contacts (2) before tacking.

10. The method as claimed in one of the preceding claims, wherein the chips (4) are bonded permanently to the function layer (7) after tacking.

CLAIMS:

1. A method for tacking of chips onto a substrate at chip positions which are distributed on a surface of the substrate, said method comprising:

forming or applying a function layer onto the surface of the substrate,

after forming or applying the function layer onto the surface of the substrate, removing the function layer from the surface of the substrate at the chip positions at least in the region of contacts to uncover the contacts,

tacking chips onto a chip contact side of the function layer at the chip positions and contacting the chips with the contacts via contact elements.

2. The method as claimed in claim 1, wherein the method further comprises:

treating the function layer with a solvent on the chip contact side in order to induce an adhesion property which is necessary for tacking.

3. The method as claimed in claim 1, wherein the method further comprises:

providing an adhesion layer onto the chip contact side of the function layer.

4. The method as claimed in claim 1, wherein the method further comprises:

after forming or applying the function layer onto the surface of the substrate, removing the function layer from the surface of the substrate outside the chip positions, thereby providing an exposed area of the surface of the substrate outside of the chip positions.

5. The method as claimed in claim 1, wherein the step of removing the function layer from the surface of the substrate includes formation of channels in the function layer.

6. The method as claimed in claim 1, wherein the function layer is comprised of a material having low elasticity.

7. The method as claimed in claim 1, wherein the step of removing the function layer from the surface of the substrate to uncover the contacts takes place by photostructuring.

8. The method as claimed in claim 1, wherein

the step of removing the function layer from the surface of the substrate to uncover the contacts includes forming through openings in the function layer when uncovering the contacts, said openings extending through the function layer to the contacts.

9. The method as claimed in claim 1, wherein the method further comprises:

aligning the chips with the contacts before tacking.

10. The method as claimed in claim 1, wherein the method further comprises:

permanently bonding the chips to the function layer after tacking.

11. The method as claimed in claim 2, wherein the function layer is treated with the solvent on the chip contact side immediately before tacking.

12. The method as claimed in claim 4, wherein the step of removing the function layer from the surface of the substrate outside the chip positions, thereby providing the exposed area, takes place by photostructuring.

13. The method as claimed in claim 12, wherein the photostructuring includes the following steps:

exposure of the function layer on areas which are to be uncovered,

lithography of the areas which are to be uncovered, and

stripping of the areas which are to be uncovered.

14. The method as claimed in claim 5, wherein formation of the channels takes place by photostructuring.

15. The method as claimed in claim 14, wherein the photostructuring includes the following steps:

exposure of the function layer on areas which are to be uncovered,

lithography of the areas which are to be uncovered, and

stripping of the areas which are to be uncovered.

16. The method as claimed in claim 5, wherein the channels are formed in the function layer beginning from the contacts.

17. The method as claimed in claim 5, wherein the channels are formed in the function layer ending on an exposed area of the surface of the substrate located outside of the chip positions.

18. The method as claimed in claim 7, wherein the photostructuring includes the following steps:

exposure of the function layer on areas which are to be uncovered,

lithography of the areas which are to be uncovered, and

stripping of the areas which are to be uncovered.

19. The method as claimed in claim 8, wherein said openings are arranged concentrically to the contacts.

20. The method as claimed in claim 8, wherein said openings in the function layer have a diameter D1 that is greater than a diameter D2 of the contact elements.

21. A method for tacking of chips onto a substrate at chip positions which are distributed on a surface of the substrate, said method comprising:

forming or applying a function layer onto the surface of the substrate;

after forming or applying the function layer onto the surface of the substrate, removing the function layer from the surface of the substrate at the chip positions at least in the region of contacts to uncover the contacts; and

tacking chips onto a chip contact side of the function layer at the chip positions and contacting the chips with the contacts via contact elements, wherein the ratio of (i) a distance between contact elements to (ii) a height difference between a lower surface of each chip and the surface of the substrate, is between 3:1 and 1:2.